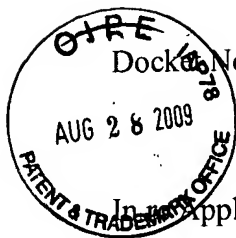


08-31-09

JFW



Docket No.: 085027-0106

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

Hui-Mei Chen, et al.

Application No.: 10/786,807

Filed: February 25, 2004

For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

: Customer Number: 41552
:
: Confirmation Number: 89518
:
: Group Art Unit: 2822
:
: Examiner: AU, BAC H
:

TRANSMITTAL OF POWER OF ATTORNEY

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Power Of Attorney to Prosecute Applications Before the USPTO, together with a Statement Under 37 CFR 3.73(b), which revokes all previous powers of attorney given in the above-identified application and associates the application with Customer Number 89518.

Respectfully submitted,

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Date: August 28, 2009

**Please recognize our Customer No. 89518
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08-31-09



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